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Microlithography NA TC Chapter
Official Virtual TC Chapter Meeting
Tuesday, Oct 31, 2023
09:00 to 11:00 AM Pacific

Agenda

1.0   Call to Order
    1.1   Introduction
    1.2   Required Meeting Elements
- Standards Membership Requirement
- Antitrust Reminder
- Intellectual Property Reminder
- International Meeting Guidelines

    1.3   Agenda Review

2.0   Review & Approval of Previous Meeting Minutes: March 28, 2023

3.0   SEMI Staff
    3.1   SEMI Staff Report

4.0   Ballot Review
4.1 Doc.7026, Reapproval of SEMI P44-1216, Specification For Open Artwork System Interchange Standard (OASIS®) Specific To Mask Tools

4.2 Doc. 7027, Reapproval of SEMI P39-0416, Specification For OASIS® – Open Artwork System Interchange Standard

5. Task Force Reports
    5.1   Curvilinear Format TF
    5.2   Mask Orders TF
    5.3   Patterning Metrology TF
    5.4   P47 Revision TF

7.0   Old Business
    7.1   Standards due for Five-Year Review
    7.2   SNARFs approaching 3-year Document Development Period
    7.3   Previous Action Items

8.0   New Business
    8.3   Action Items

9.0   Next Meeting and Adjournment